

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Keigo NAGAO, Tetsuro KUNISAWA, Tetsuo YAMADA
Serial No. :
For : **METHOD OF PRODUCING PIEZOELECTRIC THIN FILM
DEVICE AND PIEZOELECTRIC THIN FILM DEVICE**
Filed : herewith
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Ronald R. Santucci

(Typed or printed name of person mailing paper or fee)

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PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Dear Sir:

Preliminary to the examination of the above referenced patent application,

Applicants respectfully request that the application be amended as follows: